Gas Purifiers

Helium and Nitrogen Purifiers

Carrier gas purity is essential in any application requiring extreme sensitivity. Impurities limit detector sensitivity and can even destroy capillary columns. The Valco HP2 provides "point-of-use" purification of helium or other noble gases, such as Ar, Ne, Kr, and Xe, to sub-ppm levels of reactive gaseous impurities. The NP2 is similar, purifying nitrogen to sub-ppm levels of gaseous impurities.

The purification substrate in Valco gas purifiers is a non-evaporable gettering alloy. This stable alloy is contained in a welded assembly, so the purifiers can be used safely in industrial applications with minimal precautions. The getter is activated by heating, which eliminates the oxide film on the particle surface and allows helium to diffuse into the bulk of the getter particles. The HP2 and NP2 feature a self-regulating design which eliminates the possibility of thermal runaway and maintains the getter material at the optimum temperature.



Standard helium and nitrogen purifiers

Includes universal power supply.

Helium purifier Nitrogen purifier

Description Prod No Prod No

110 VAC HP2 NP2
230 VAC HP2-220 NP2-220

Replacement getter assembly

Helium I-23572HP2 Nitrogen I-23572NP2

HELIUM PURIFIER

■ CE certified

■ Gases purified He, Ne, Ar, Kr, Xe, Rn

■ Maximum operating pressure 1000 psig

Impurities removed

Outlet impurities less than 10ppb H_2O , H_2 , O_2 , N_2 , NO, NH_3 , CO, CO_2 , and CH_4 , based on 10ppm total inlet impurities. Other impurities removed include CF_A , CCI_A , SiH_A and light hydrocarbons.

■ Impurities *not* removed He, Ne, Ar, Kr, Xe, Rn

NITROGEN PURIFIER

CE certified

Gases purified N_2 only

Impurities removed

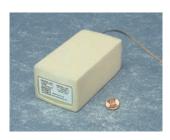
Outlet impurities less than 10ppb $\rm H_2O, \rm H_2, \, O_{2^t}$ NO, NH $_3$, CO, CO $_{2^t}$ and CH $_{4^t}$ based on 10ppm total inlet impurities. Other impurities removed include $\rm CF_{4^t} \, CCI_{4^t} \, SiH_4$ and light hydrocarbons.

■ Impurities *not* removed

He, Ne, Ar, Kr, Xe, Rn, N₂

CHROMalytic TECHnology Pty Ltd AUSTRALIAN Distributors e-mail: sales@chromtech.net.au Tel: 03 9762 2034

Gas Purifier and Thermal Conductivity Detector



Miniature Gas Purifiers

The Valco Miniature Helium Purifier (HPM) and Miniature Nitrogen Purifier (NPM) are designed to be installed in a gas chromatograph's flow path immediately upstream of the injector.

The HPM/NPM will remove any contaminants introduced by flow controllers, elastomeric tube seals, pressure regulators, crude traps, or other system components that are not completely clean and leak-tight.

Mini helium and nitrogen purifiers

Includes universal power supply.

Helium purifier Nitrogen purifier

Description Prod No Prod No

110 VAC HPM NPM
230 VAC HPM-220 NPM-220